

	Type	Hits	Search Text	DBs
18	BRS	306	(((((undercut\$ or (under adj1 cut\$4)) with (etch\$ or rie)) and (photoresist or resist\$4)) and (mask\$4 or hardmask)) and ((polysilicon or (poly adj1 (si or silicon)) or silicon) same (gate or electrode))) and (((438/299-308) or (438/584-596)).CCLS.)	USPAT; US-PGPUB
19	BRS	795	(isotropic\$ with (etch\$ or rie)) and (photoresist or resist\$4) and (mask\$4 or hardmask) and ((polysilicon or (poly adj1 (si or silicon)) or silicon) same (gate or electrode)) and (((438/299-308) or (438/584-596)).CCLS.)	USPAT; US-PGPUB

	Time Stamp	Comments	Error Definition	Errors
18	2004/08/16 10:39			0
19	2004/08/16 10:38			0